

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Jules Cla 12013

## In re Application of:

Salman Akram

Serial No.: 09/829,161

Filed: April 9, 2001

For: METALLIZATION STRUCTURES
FOR SEMICONDUCTOR DEVICE
INTERCONNECTS, METHODS FOR
MAKING SAME, AND
SEMICONDUCTOR DEVICES
INCLUDING SAME

Confirmation No.: 8260

Examiner: H. Nguyen

Group Art Unit: 2812

Attorney Docket No.: 2269-3442.1US

(96-0428.01/US)

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

5/13/2003

Date

Signature

Joseph A. Walkowski Name (Type/Print)

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# AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF Commissioner for Patents P. O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed March 21, 2003, the three-month shortened statutory period for

## Serial No. 09/829,161

response to which expires on June 21, 2003. This response is submitted on or before two months from the mailing date of the Final Office Action.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 14 of this paper.